

Notice of References Cited	Application/Control No. 10/697,094	Applicant(s)/Patent Under Reexamination SAGA ET AL.	
	Examiner Natalia Figueroa	Art Unit 2651	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-6,636,460 B2	10-2003	Akiyama et al.	369/13.14
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	M	US-			

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	N	JP2001-255254	09-2001	Japan	Takuya et al.	
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	V	Ito et al., "Advanced Recording Method Using a Near-Field Optics and the GMR Head", May 2000,Conference Digest Optical Dtat Storage, pages 30-32.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.